

Notice of References Cited		Application/Control No. 10/825,673	Applicant(s)/Patent Under Reexamination ENDO ET AL.	
		Examiner CHIA-WEI A. CHEN	Art Unit 2622	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,887,107	12-1989	Nakamura et al.	396/75
*	B	US-6,978,089	12-2005	Nomura et al.	396/75
*	C	US-4,969,719	11-1990	Bradshaw et al.	349/116
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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